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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL. NUM. 10022364	FILING DATE 12/20/2001	CLASS 130	SUBCLASS 455	GAU. 182 284	EXAMINER S. FOONG J. E. King
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***APPLICANTS: Kuhl, Francis; Howell, Earl;

***CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO.
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	N.C. 79,684
Verified and Acknowledged Examiners's initials <i>sf</i>		
TITLE : Method for transferring thin film layer material to a flexible substrate using a hydrogen ion splitting technique		

U.S. DEPT. OF COMM./PAT. & TM. PTO-456L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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